

Search Notes 	Application/Control No. 10/634,331	Applicant(s)/Patent under Reexamination POLITO ET AL.
	Examiner Ja-Na Hines	Art Unit 1645

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
updated previous database searches including search of related applications and patents		
Consulted Primary Chen about the Zweig rejection and applicant's argument. It was decided to maintain the rejection because the plates of Zweig have to some structure and are capable of performing the capacitance sensing. The claim amt. does not add any limitation.		11/10/04